Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	70	electrooptic adj system	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/03/01 16:03
L3	24	(plurality adj apertures) and (charge adj particle adj beams)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/01 15:40
L4	162	(plurality adj apertures) and (conductive adj shield)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/01 15:43
L5	92	(plurality adj apertures) and (metal adj shield)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/01 15:44
L6	600	(plurality adj first adj apertures)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/01 15:46
L7	40	(plurality adj first adj apertures) and (laser)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/01 15:47
L8	71	(plurality adj first adj apertures) and (beam)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/01 15:48
L9	74	(first adj layer adj apertures)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/01 15:50

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L10	215	(first adj layer adj vias)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/01 15:50
L11	43	(first adj layer adj vias) and beam	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/01 15:51
L12	34	(first adj layer adj vias) and laser	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/01 15:52
L13	74	(first adj layer adj vias) and light	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/01 15:53
L14	44	(first adj layer adj holes) and light	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/01 15:54
L15	28	(first adj layer adj holes) and laser	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/01 15:54
L16	29	(first adj layer adj holes) and beam	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/01 15:55
L19	103	(plurality adj holes) near (beam or laser or light)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/01 15:56

L20	123	(plurality adj vias) with (beam or laser or light)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/01 15:57
L22	159	(plurality adj apertures) near (beam or laser or light)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/01 15:57
L23	87	(conductive adj shield) adj between	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/01 16:00
L24	29	(conductive adj shield) adj interposed	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR.	ON	2005/03/01 16:00
L25	398	electrooptical adj system	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/03/01 16:03